

INFORMATION DISCLOSURE STATEMENT				Page <u>1</u> Of <u>1</u>			
				Atty. Docket No. FUK-12CPA		Serial No.	
				Applicant Migaku Takahashi			
				Filing Date September 18, 2003		Group 1753	
U.S. PATENT DOCUMENTS							
Examiner Initial *		Document No.	Date	Name	Class	Subclass	Filing Date
<i>mu</i>	AA	5,736,264	7/98	Ishiwata et al.	G11B	5/66	3/93
	AB	5,382,305	1/95	Terunuma et al.	H01F	10/00	8/93
	AC	5,173,370	12/92	Takahashi et al.	G11B	5/00	8/90
	AD	5,465,475	11/95	Kinoshita et al.	G11B	5/42	7/93
	AE	5,401,609	3/95	Haratani et al.	G11B	1/24	6/94
	AF	5,334,433	8/94	Tominaga	B32B	3/00	12/92
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	AK	5,659,537	08/97	Hirokane et al	G11B	07/00	06/95
<i>mu</i>	AL	5,687,045	11/97	Okai et al	G11B	05/31	11/95
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		Document No.	Date	Country	Class	Subclass	Translation
							Yes No
<i>mu</i>	AM	59-45911	3/84	Japan	C01B	21/06	3/82
	AN	62-164868	7/87	Japan	C23C	14/06	1/86
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	AQ	62-285406	12/87	Japan	H01F	10/10	6/86
	AR	2-109309	4/90	Japan	H01F	10/14	10/88
<i>mu</i>	AS	60-25211	2/85	Japan	H01F	41/18	7/83
OTHER REFERENCES (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)							
<i>mu</i>	AT	Journal of Applied Physics 53 (11), November 1982. Pp. 8332-8334. "Metastable Fe Nitrides with High Bs Prepared by Reactive Sputtering". A. KANO, N.S. KAZAMA, H. FUJIMORI					
EXAMINER: <i>Tracy (M. Donald)</i>				DATE CONSIDERED: <i>7/14/05</i>			
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							